



JPW

Docket No.: R2184.0162/P162-A  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Miho Okazaki

Application No.: 10/798,356

Art Unit: 2815

Filed: March 12, 2004

Examiner: A. R. Wilson

For: SEMICONDUCTOR APPARATUS WITH  
IMPROVED ESD WITH STANDING  
VOLTAGE

AMENDMENT

MS Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action mailed September 27, 2004 (Paper No. 0904),  
please amend the above-identified U.S. patent application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins  
on page 3 of this paper.

**Remarks** begin on page 5 of this paper.